

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Eric Bornstein

Application Serial No.:

10/649,910

Filing Date:

26 August 2003

Title:

NEAR INFRARED MICROBIAL ELIMINATION LASER SYSTEM

Examiner:

Shay, David M.

Art Unit:

3735

Confirmation No.:

5770

Atty. Docket No.:

072287-0019

CERTIFICATE OF MAILING OR TRANSMISSION

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TRANSMITTAL LETTER

Enclosed for filing in connection with the above-referenced patent application is an Information Disclosure Statement by Applicant, with a copy of the cited reference attached.

The Commissioner is authorized to charge the \$180 Information Disclosure Statement Fee, further fees which may be due and/or credit any over payment to Deposit Account No. 50-1133.

Respectfully submitted,

Date: 12 March 200 7

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الفذ Subst. for form 1449/PTO Complete if Known INFORMATION DISCLOSURB STATEMENT **Application Number** 10/649,910 BY APPLICANT Filing Date 08/26/2003 (Use as many sheets as necessary First Named Inventor Bornstein MAR 1 4 2007 Art Unit 3735 **Examiner Name** Shay, David M. 072287-0019 3 **Docket Number** Sheet

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^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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